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Appl. No. 10/621,497 Amdt. Dated May 12, 2005

Reply to Office action of April 18, 2005

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1) l. No.

10/621,497

plicant

Tetsuhiro Iwai et al.

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July 17, 2003

Title

PLASMA PROCESSING APPARATUS AND PLASMA

PROCESSING METHOD

Conf. No. TC/A.U.

2610

Examiner

1765 Lan Vinh

Customer No.

000,116

Docket No.

35908

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE "B" AND ELECTION

Sir:

This communication is filed in response to the Office action dated April 18, 2005 (Paper No. 041205). The one month period for responding to the Office action expires on May 18, 2005.

Remarks begin on page 2 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Michael W. Garvey

May 12, 2005

Name of Attorney for Applicant(s)

Signature of Attorney/Date